



Attorney Docket No. 0756-7283

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

) Group Art Unit: 2814

Koichiro TANAKA et al.

) Examiner: A. Chambliss

Serial No. 10/815,813

) CERTIFICATE OF MAILING
I hereby certify that this correspondence is
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Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on January 13,
2006.

Filed: April 2, 2004

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For: LASER IRRADIATION METHOD,
LASER IRRADIATION APPARATUS
AND METHOD FOR
MANUFACTURING
SEMICONDUCTOR DEVICE

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RESPONSE TO ELECTION REQUIREMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the election requirement in the Office Action of December 13, 2005, Applicant hereby elects without traverse Species A2 directed toward patterning a crystalline semiconductor film and forming a channel in semiconductor layer. Claims 29-46 read on the elected species. Further, claims 1-18 are generic in that these claims do not recite features designated in either species A1 and A2.

Thus, claims 1-18 and 29-46 are subject to examination at this time.

Examination on the merits is requested.

Respectfully submitted,

Eric J. Robinson
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